

ELIONIX

Electron Beam Lithography System

ELS-BODEN

Perfect for research and development!



ECR Ion Beam Sputter System

ELS-200ERP

Compact but High Performance!

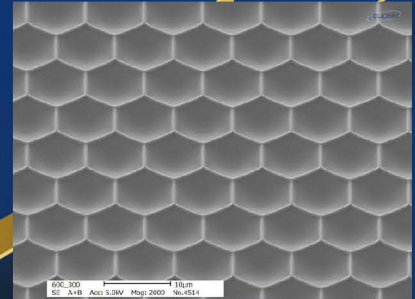
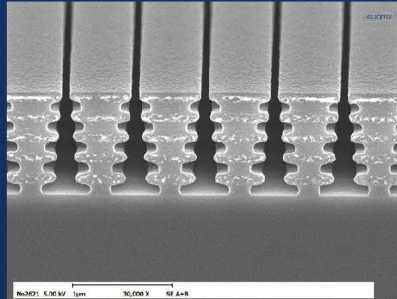
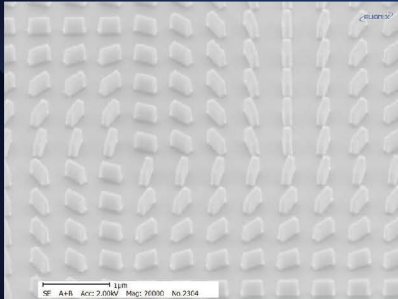


EIS 1500

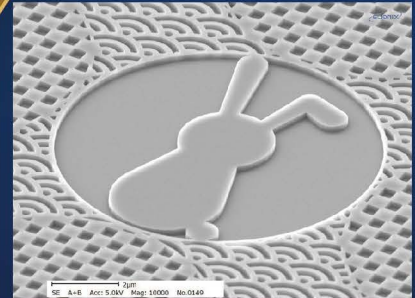
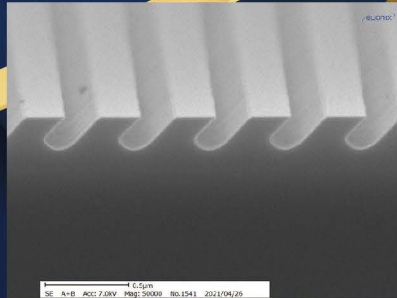
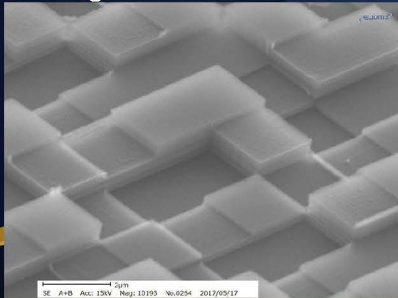
φ108 mm Large diameter beam!



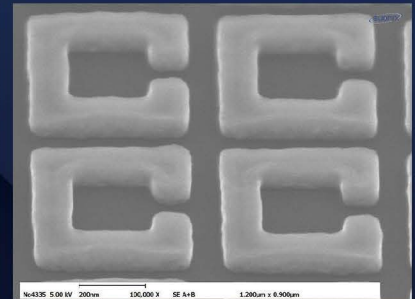
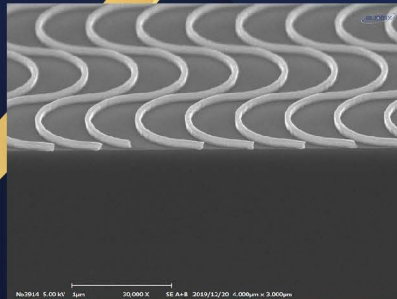
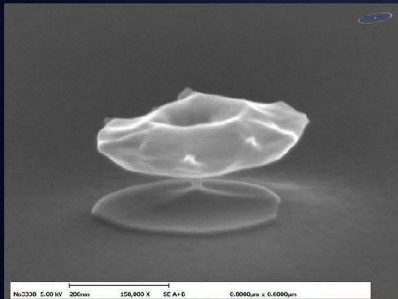
Resist Pattern



Etching Pattern



Lift-off Pattern



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